

00862.023488



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Haruhito ONO et al.) : Examiner: N. Wells
Application No.: 10/787,082) : Group Art Unit: 2881
Filed: February 27, 2004) : Confirmation No.: 4298
For: DEFLECTOR, METHOD OF MANUFACTURING) : Allowed: February 16, 2005
DEFLECTOR, AND CHARGED PARTICLE BEAM : April 12, 2005
EXPOSURE APPARATUS USING DEFLECTOR)

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

LETTER TRANSMITTING CORRECTED FORMAL DRAWINGS

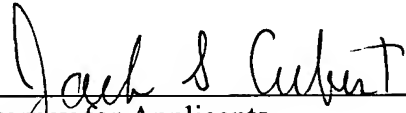
Sir:

Transmitted herewith are four (4) formal drawing replacement sheets, corrected Figures 1-4B, to be substituted for the corresponding drawing sheets currently on file in the above-identified application.

Figures 1-4B incorporate the changes required by the Examiner in the Notice of Allowability dated February 16, 2005.

Applicants' attorney, Steven E. Warner, may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address listed below.

Respectfully submitted,

A handwritten signature in dark ink, appearing to read "Jack S. Cubert", written over a horizontal line.

Attorney for Applicants

Jack S. Cubert

Registration No. 24,245

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3800
Facsimile: (212) 218-2200

DC_MAIN 199373v1